

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
 )  
Shunpei Yamazaki et al. )  
 )  
Serial No.: 09/724,002 )  
 )  
Filed: November 28, 2000 )  
 )  
For: Film Deposition Apparatus And )  
Method Of Manufacturing A Light )  
Emitting Device Using The )  
Apparatus )  
 )  
Art Unit: 1763 )  
 )  
Confirm No.: 7243 )  
 )  
Examiner: K. Moore )

Commissioner for Patents  
P.O. Box 1450  
Alexandra, VA 22313-1450

**AMENDMENT J**

Sir:

Applicants have the following response to the Final Rejection of July 23, 2007, a RCE being filed herewith.

Please amend in the above-identified application as follows: